

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Satoshi Hayashi et al.

Serial No.: 10/581,578

Filed: June 2, 2006

For: ANION ADSORBING CARBON
MATERIAL, AS WELL AS
MANUFACTURING METHOD AND
MANUFACTURING FACILITIES

Group Art Unit:

December 20, 2006

Costa Mesa, California 92626

INFORMATION DISCLOSURE STATEMENT

Mail Stop PCT
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In an attempt to fully comply with the duty of disclosure set forth in 37 C.F.R. § 1.56 and in conformance with 37 C.F.R. §§ 1.97 and 1.98, applicant wishes to bring to the attention of the U.S.

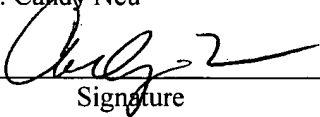
Patent Office the following references:

Japanese Patent Application Publication No. 2001-232384 w/English translation
Japanese Patent Application Publication No. 52-009974 w/English translation
Japanese Patent Application Publication No. 05-098942 w/English translation
Japanese Patent Application Publication No. 05-247470 w/English translation
Japanese Patent Application Publication No. 11-106751 w/English translation
Japanese Patent Application Publication No. 54-033293 w/English translation
Japanese Patent Application Publication No. 09-314131 w/English translation
Japanese Patent Application Publication No. 09-122490 w/English translation
Japanese Patent Application Publication No. 09-225454 w/English translation
Japanese Patent Application Publication No. 63-129007 w/English translation
Japanese Patent Application No. 52-34260
Japanese Patent Application No. 52-16363
Japanese Patent Application No. 48-93591

Copies of these references and Form PTO-A820 are attached.

If the Examiner believes that a telephone conference would help further the prosecution of this case, he is respectfully requested to contact the undersigned attorney at the listed telephone number.

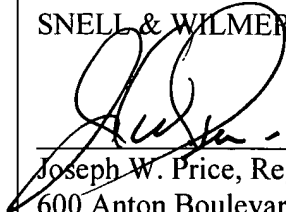
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Very truly yours,

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INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>				Docket Number (Optional)		Application Number		
				42479-9400		10/581,578		
				Applicant(s)				
				Satoshi Hayashi et al.				
Filing Date				Group Art Unit				
				6/2/2006				
U. S. PATENT DOCUMENTS								
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
U.S. PATENT APPLICATION PUBLICATIONS								
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
		2001-2323894	28.08.2001	Japan			X	
		52-009974	25.01.1977	Japan			X	
		05-098942	20.04.1993	Japan			X	
		05-247470	24.09.1993	Japan			X	
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		52-34260	1977.3.16	Japan				X
		52-16363	1977.2.7	Japan				X
		48-93591	1973.12.4	Japan				X
OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>								
EXAMINER				DATE CONSIDERED				
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								